OIPE
JAN 0 4 2007
PATENT & TRADEMARK OFFICE

Attorney Docket No. 0756-7209

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	Group Art Unit: 2823
Shunpei YAMAZAKI et al.	)	Examiner: Phillip Green
Serial No. 10/678,083	)	
Filed: October 6, 2003	)	
For: METHOD OF IRRADIATING LASER, LASER IRRADIATION SYSTEM, AND MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE	)	

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 28, 2006.

Ashlee M Stamper

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated September 28, 2006, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on 8 of this paper.